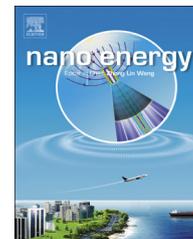




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RAPID COMMUNICATION

Piezotronic effect enhanced detection of flammable/toxic gases by ZnO micro/nanowire sensors



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Received 23 December 2014; received in revised form 21 January 2015; accepted 22 January 2015

Available online 2 February 2015

KEYWORDS

Piezotronic effect;
Flammable/toxic gas sensors;
ZnO micro/nanowire;
Schottky-contact;
Room-temperature

Abstract

Compared with conventional Ohmic-contact nanosensors, Schottky-contact has been introduced as a fundamentally new design for much enhanced sensitivity and improved responsive time of one-dimensional nanostructure based sensors. Here we demonstrate ZnO micro/nanowire sensors for hydrogen (H₂) and nitrogen dioxide (NO₂) detections at room-temperature based on a metal-semiconductor-metal (M-S-M) structure. By utilizing strain-induced piezoelectric polarization charges presented at the vicinity of local interface to modify the band structure at Schottky contact, piezotronic effect has been introduced to gate/modulate the charge carriers transport process across the M-S contact and thus hugely enhance/optimize the performances of H₂/NO₂ gas sensors. Upon straining, the detection sensitivity and resolution are obviously improved, together with a significant enhancement in output current by 5359% for H₂ and 238.8% for NO₂ detection. This work provides a promising approach to raise the sensitivity, improve the detection resolution, and generally enhance the performance of gas sensing, making it possible for fabricating room temperature of gas sensor while preserving its sensitivity.

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Introduction

Monitoring and quantifying the amount of flammable/toxic gas in the ambient environment is of great importance to both personal and environmental safeties. Especially for those

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colorless, odorless and tasteless hazardous gases such as hydrogen (H_2) or poisonous and irritant gases such as nitrogen dioxide (NO_2), it is essential to detect them quantitatively to prevent potential explosion or poisoning, since general human senses cannot distinguish their presences. One-dimensional (1D) nanostructures such as nanowires [1,2], nanorods [3] and nanobelts [4,5] have been extensively investigated for ultra-sensitive and fast-response gas sensing [6-9] due to their unique structural characteristics and versatile physical properties, such as high volume-to-surface ratio and short-transport path for carriers. Although promising results have been reported for Ohmic-contact nanosensors for gas detections [10-12], further improvements on the sensing performances remain challenging since the manipulation and fabrication process become extremely difficult and expensive when miniaturizing the nanostructure to ensure small contact areas. Low-cost and easy-fabricated Schottky-contact structure nanosensor, on the other hand, is considered as a prospective alternate for gas sensing applications with ultra-high sensitivity and fast response time, since the sensing functionality depends on interfacial carrier transport, which is a more effective and sensitive working mechanism [13].

Piezotronic effect [14], usually existing in wurtzite/zinc blend family materials, has been recently reported as an efficient approach to directly gate the transport properties of the carrier in the semiconductor [15,16] or to tune/control the Schottky barrier height (SBH) through modifying the band structure at local M-S contacts upon straining [17-19]. The strain-induced piezoelectric polarization charges presented at the vicinity of local interface effectively gate/modulate the charge carriers transport process across the energy barrier, and thus enhance/optimize the performances of Schottky-contact structured nanosensors of various categories, including chemical [20,21], biological [22], optical [23,24] and humidity sensing [25]. Therefore, piezotronic effect is universal to different types of Schottky-contact sensors as an effective approach to improve the sensitivity and enhance/optimize their general performances.

In this work, we designed and fabricated Schottky-contact ZnO micro/nanowire sensors for flammable/toxic gas detections. By surface decorating the ZnO nanowire (NW) with Pd nanoparticles for catalytic dissociation of H_2 to atomic hydrogen [26,27], hydrogen detection is demonstrated since the adsorbed hydrogen atoms acting as donors to induce a charge accumulation layer on the NW surface [28], and thus increasing the carrier density within n-type ZnO NWs. By exposing ZnO NW devices to NO_2 atmosphere, the strong oxidizing NO_2 molecules act as electron acceptors, are easily to bind in the preferential adsorption sites provided by the oxygen vacancies at the oxide surface and are more inclined to capture electrons from the conduction band and form NO_2^- [29]. Subsequently, a charge depletion layer produced near the surface [30], which effectively decreases the conductivity of the device. Piezotronic effect is introduced by externally applying strains to the ZnO micro/nanowire sensors to enhance/optimize their performances. Experimental results show that the detection sensitivity and resolution are obviously improved; the output current is significantly enhanced by 5359% for H_2 and 238.8% for NO_2 detection. Strain-induced piezo-polarization charges play an essential role in modifying the band structure at M-S contact and hence gating the charge carrier transport process across the Schottky

barrier. This study provides a promising approach to improve the detection sensitivity and enhance the general performance of Schottky-contact gas sensors, making it possible for fabricating room-temperature gas sensor while preserving its sensitivity.

Experimental section

ZnO micro/nanowire synthesis and characterization

ZnO micro/nanowires were synthesized *via* vapor-liquid-solid (VLS) method [31,32]. An alumina boat (3.5 cm \times 6.5 cm) loaded with a mixture of 1 g ZnO and 1 g carbon powders was placed in the center of a tube furnace, a silicon substrate coated with 5 nm Au was placed on the top of the alumina boat with the Au layer facing down. The typical synthesis procedure was carried out at a temperature of 1000 °C with the flow rate of nitrogen gas at 100 standard cubic centimeters per minute (sccm) for 1 h. The ZnO micro/nanowires were characterized by SEM (SU8020). After the ZnO synthesis process, Pd nanoparticles were fabricated by radio frequency (RF) sputtering at room temperature. The ZnO micro/nanowires substrate was deposited in a vacuum chamber with the flow rate of argon at 100 sccm, with RF power of 100 W for 20 s.

Device fabrication

The single micro/nanowire gas sensor was fabricated by transferring and bonding an individual ZnO/Pd or ZnO micro/nanowire onto a flexible polystyrene (PS) substrate, with its *c*-axis parallel to the longitudinal direction of the PS substrate. Then silver paste was used to fix both ends of the micro/nanowire and also served as source and drain electrodes.

Measurement and piezotronic effect on a single micro/nanowire gas sensor

One end of the as-fabricated device was fixed inside the gas chamber. The other end of the device was free to be bent by a positioner controlled from outside the chamber with a displacement resolution of 1 μ m.

For H_2 detection, high concentration hydrogen gas (800 ppm) diluted with nitrogen gas was introduced to the sensor in appropriate concentrations through mass flow controller (BEQ, GMF-3Z), with the total flow rate fixed at 100 sccm. The sensing performance of the device was studied at room temperature by measuring the current changes of the device when switching the sensing chamber environment from air to H_2 in a periodic manner, with H_2 concentration ranging from 80 to 320 ppm. *I-V* characteristics of the device at different strains in gas environment with different H_2 concentrations were recorded through Stanford research systems (SR570 and DS345).

For NO_2 measurement, high concentrations NO_2 gas (800 ppm) diluted with nitrogen gas was introduced into the chamber through mass flow controller (BEQ, GMF-3Z), with the flow rate fixed at 100 sccm. The sensing performance of the device was studied in the same method as that used for H_2 detection, with NO_2 concentration ranging from 160 to 800 ppm.

Results and discussion

High-quality ZnO micro/nanowires used in this work were grown by a vapor-liquid-solid process at 1000 °C, with lengths of several hundreds of microns and diameters varying from tens of nanometers to several microns (Fig. 1a). An enlarged SEM image of an individual ZnO NW is shown as the inset of Fig. 1a. Schematic illustrations of the experimental setup are presented in Fig. 1b, showing that one end of the device is fixed inside the chamber, while the other end is free to be bent by a positioner through a 3D mechanical stage with movement resolution of 1 μm . An optical image of the as-fabricated ZnO micro/nanowire gas sensor is shown in the inset of Fig. 1b, with detailed fabrication process described in the aforementioned part. The response of ZnO micro/nanowire sensors to flammable/toxic gas is evaluated by measuring its transport characteristics under different gas concentrations at room temperature, with bias voltage fixed at 3 V for H_2 sensor and 5 V for NO_2 sensor, respectively.

The current response of a Pd-functionalized ZnO micro/nanowire H_2 sensor is presented in Fig. 1c. By varying the hydrogen concentrations inside the measuring chamber, the current of the sensor increases stepwise with the hydrogen concentrations from 0.56 μA (80 ppm) to 0.82 μA (320 ppm), showing a sensitive response to the hydrogen atmosphere changes. The response time is about 100 s, the recovery time is about 10 s. There is a slightly current increase in N_2 atmosphere, which is consistent with the expected surface

electron-depletion layer created by the chemisorbed oxygen species on the surface of the ZnO in air [13]. The observed response and recover properties of the Pd-functionalized H_2 sensor are mainly contributed to the “spillover effect” reported previously by others [33]. Performances of a ZnO micro/nanowire NO_2 sensor are shown in Fig. 1d, which is obtained by applying a 253.7 nm UV illumination for 10 min before the measurements to pre-remove the oxygen adsorbed on the ZnO surface. The current decreases with the increase of the NO_2 concentration from 3.20 μA (160 ppm) to 2.87 μA (800 ppm). The response time is about 60 s, and the recovery time is about 30 s. It can be seen that the current incompletely recovers to the original level after evacuating the NO_2 in each cycle, indicating a partial desorption and decomposition process of the main adsorbed nitrates [34]. UV light is employed for assisting the current recovery of NO_2 sensors to original level more effectively [35].

Systematic measurements of ZnO micro/nanowire gas sensors response to H_2 and NO_2 are conducted and summarized in Fig. 2 via I - V characteristics at room temperature. Among air, 80 ppm and 320 ppm H_2 atmosphere, the Pd-functionalized H_2 sensors are measured under different strain conditions, showing increase in output current by either introducing more H_2 or applying more strains (Fig. 2a-c). For example, under strain-free condition (Fig. 2a-c, black line), the current of the gas sensor increases from 0.074 μA to 0.23 μA , then to 0.61 μA as the test environment

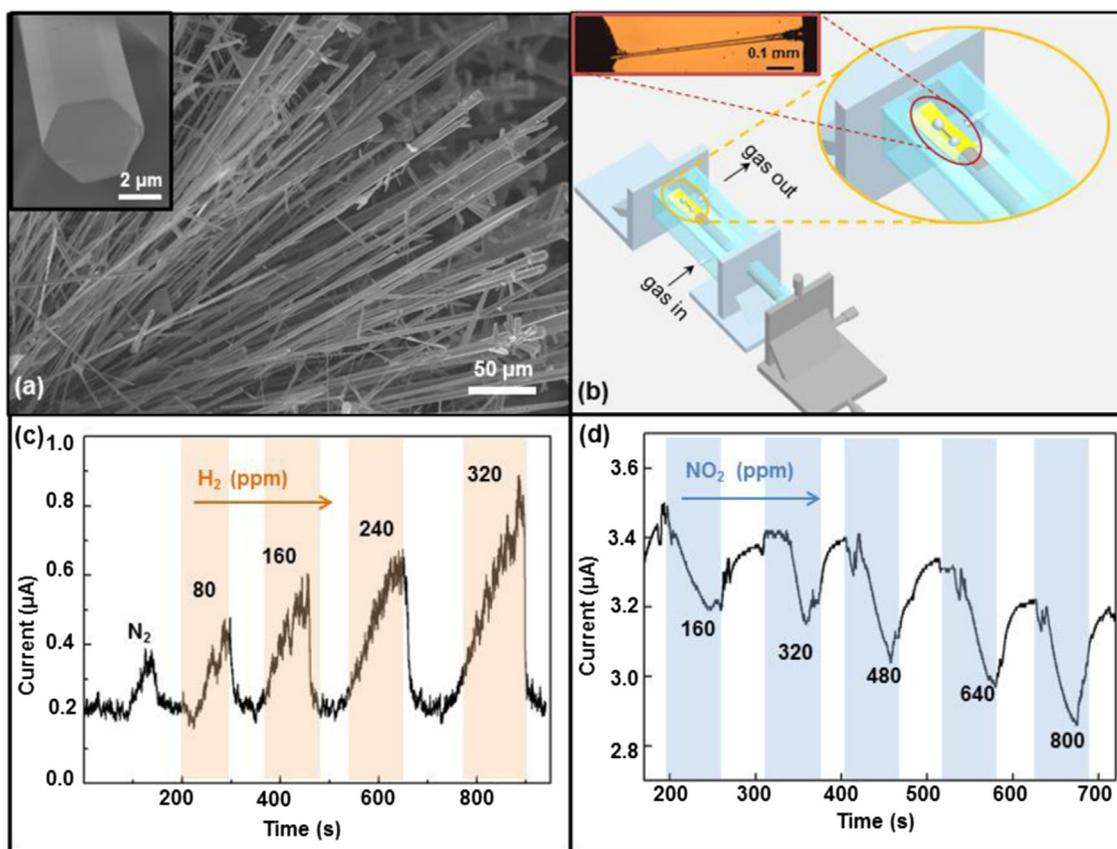


Fig. 1 (a) Scanning electron microscopy (SEM) images of the as-grown ZnO NWs. (b) Schematic illustration of the experimental setups. Inset: the optical image of an as-fabricated gas sensor device. (c) Current response of a Pd-functionalized H_2 sensor to different hydrogen concentrations. (d) Current response of a NO_2 sensor to different NO_2 concentrations.

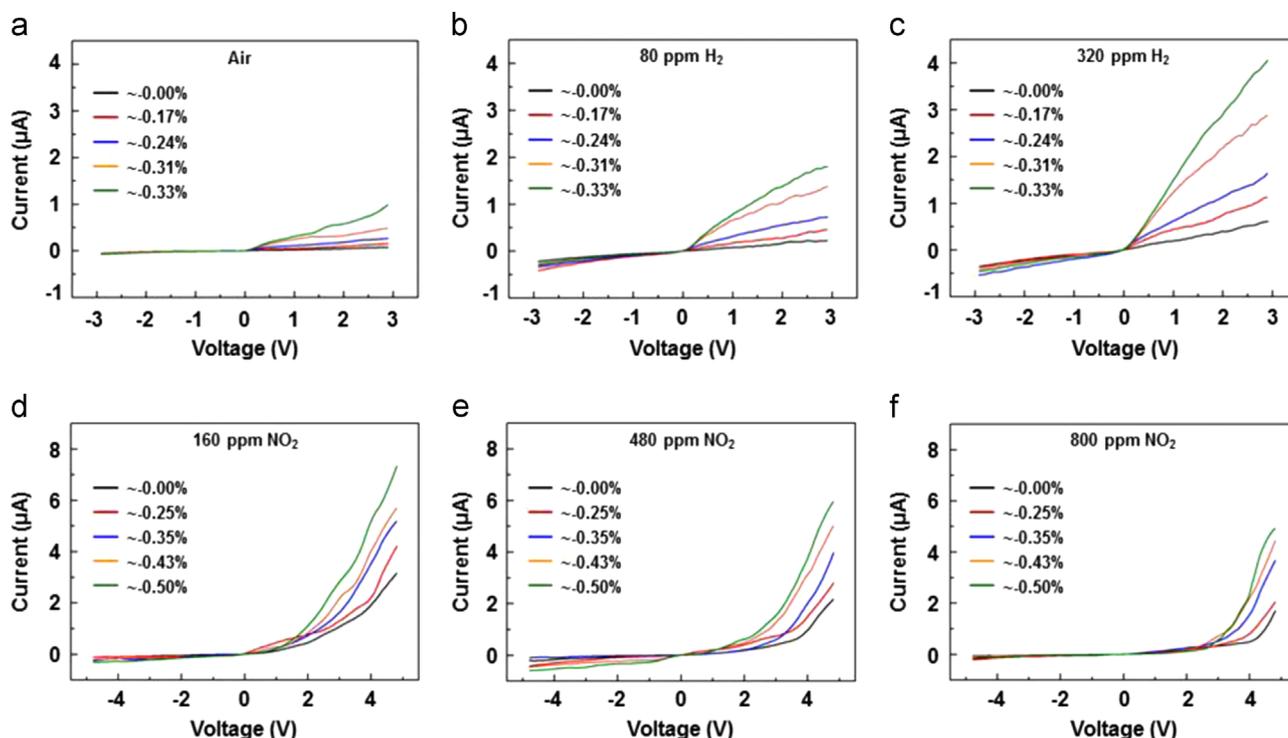


Fig. 2 General H₂ and NO₂ sensing performances. (a-c) *I*-*V* characteristics of the H₂ sensor under different compressive strains (a) in air; (b) 80 ppm and (c) 320 ppm H₂ atmosphere. (d-f) *I*-*V* characteristics of the NO₂ sensor under different compressive strains in (d) 160 ppm, (e) 480 ppm and (f) 800 ppm NO₂ atmosphere.

changes from air to 80 ppm H₂ and then to 320 ppm H₂, showing a good hydrogen response of the device. In air atmosphere, the current increases from 0.074 µA to 0.94 µA (by 1170%) as the applied compressive strain varying from -0.00% to -0.33% (Fig. 2a). In 320 ppm H₂ atmosphere, the current increases from 0.61 µA to 4.05 µA (by 564%) as the compressive strain changing from -0.00% to -0.33% (Fig. 2c). These results clearly show the significant enhancements in output current of ZnO micro/nanowire sensors under compressive strains by piezotronic effect.

Similar responses are derived for NO₂ detection as shown in Fig. 2d-f. Under strain-free condition, the current decreases from 2.88 µA to 2.10 µA and then to 1.47 µA, as the NO₂ concentration increases from 160 ppm to 480 ppm then to 800 ppm (Fig. 2d-f, black line). In 160 ppm NO₂ atmosphere, the current increases from 2.88 µA (-0.00% strain) to 7.19 µA (-0.50% strain), corresponding to an enhancement of 149.7% (Fig. 2d). In 800 ppm NO₂ atmosphere, the current increases from 1.47 µA (-0.00% strain) to 4.98 µA (-0.50% strain) with a relative change of 238.8% as shown in Fig. 2f. The enlarged output currents in different NO₂ atmosphere significantly facilitate the detection and clearly indicate the enhancements induced by piezotronic effect under externally applied compressive strains.

A 3D plot is presented in Fig. 3a to indicate the overall trend of current response to H₂ atmosphere and externally applied strain conditions for hydrogen detection, clearly showing that the current increases with the increase of H₂ concentration or compressive strain. Two corresponding 2D graphs are plotted in Fig. 3b and c to illustrate the enhancements on detecting sensitivity and sensing resolutions by piezotronic effect after applying external strains. Fig. 3b

presents the absolute current response of Pd-functionalized H₂ sensors to different H₂ concentrations, with compressive strain fixed in each curve, ranging from -0.00% to -0.33%. The detection sensitivity of H₂ sensors are characterized by the slope of each curve, showing higher sensitivity under stronger compressive strains. Fig. 3c shows the current response of H₂ sensors to different strains, with H₂ concentrations fixed in each curve (from 0 to 320 ppm). The sensing resolution is clearly improved by piezotronic effect under compressive strains, since the difference of current response between two adjacent H₂ concentrations is increased by applying more compressive strains on the devices.

To better illustrate the enhancements on detection sensitivity of hydrogen sensors by piezotronic effect, the relative current change of the Pd-functionalized H₂ sensor in different H₂ concentration and strain conditions is calculated and summarized in Fig. 3d and e, by defining the detection sensitivity as $dI/I = (I_{\text{hydrogen}, \varepsilon} - I_0)/I_0$, where I_0 is the current in air atmosphere under strain-free condition, and $I_{\text{hydrogen}, \varepsilon}$ is the current under certain H₂ concentration and strain conditions. It is obvious that the detection sensitivity under each H₂ concentration is significantly enhanced by piezotronic effect through applying compressive strains on the devices, with the highest sensitivity of 5359% in 320 ppm H₂ atmosphere, under -0.33% compressive strain (Fig. 3e). These results agree well with the increase in curve slope (Fig. 3b) and indicate the obvious enhancements on detection sensitivity of hydrogen sensors by piezotronic effect. Similar enhancements on detection sensitivity and sensing resolutions are also observed and presented in Fig. 4 for NO₂ sensors. Both the slope of *I* vs. NO₂ concentration curves and the difference between output currents corresponding to two adjacent NO₂ concentrations

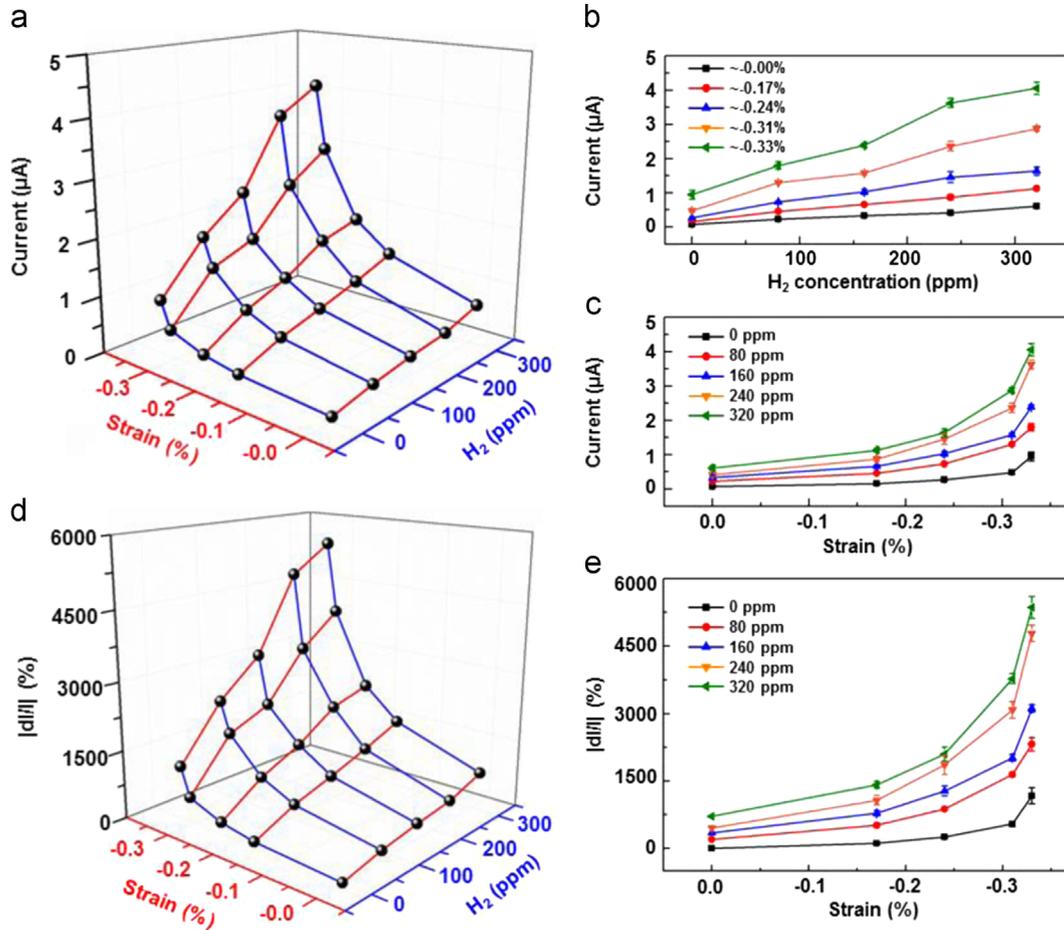


Fig. 3 Piezotronic enhancements on H_2 sensing. (a) 3D graph depicting the current response of the H_2 sensor to strain and H_2 concentrations at a bias voltage of 2.9 V. (b) Absolute current response to different H_2 concentrations, with compressive strains ranging from -0.00% to -0.33% . (c) Absolute current response to different compressive strains, with H_2 concentrations ranging from 0 to 320 ppm. (d) 3D graph and its corresponding (e) 2D projection indicating the relative changes of current under H_2 concentrations ranging from 0 to 320 ppm with respect to the value at -0.00% strain in air.

increase when applying more compressive strains, indicating the improvements to the performances of ZnO micro/nano-wire based NO_2 sensors by piezotronic effect.

The barrier height at reversely biased Schottky contact (Φ_d) and the corresponding resistances of ZnO NWs are calculated by utilizing a Matlab GUI program [36] build on an equivalent model for the M-S-M structure. In a Schottky diode under moderate bias, the current density is given by the following equation:

$$J = \frac{A \times T \sqrt{\pi E_{00}}}{k} \times \sqrt{q(V - \varepsilon) + \frac{\psi}{\cos h^2 \left(\frac{E_{00}}{kT} \right)}} \times \exp\left(-\frac{\psi}{E_0}\right) \times \exp\left(\frac{qV}{kT} - \frac{qV}{E_0}\right)$$

where ψ is the effective SBH, V is the applied bias, ε is the distance between the Fermi level to the bottom of the conduction band, T is the temperature, and A is Richardson constant. The constants E_0 and E_{00} are given by the following equation:

$$E_0 = E_{00} \coth\left(\frac{E_{00}}{kT}\right)$$

$$E_{00} = \frac{\hbar q}{2} \times \sqrt{\frac{N_d}{m^* \varepsilon_s \varepsilon_0}}$$

where m^* is the effective mass, N_d

is the doping concentration and $\varepsilon_s, \varepsilon_0$ are the relative permittivity of the ZnO NW and the absolute permittivity of free space. In the M-S-M structure, a linear region is expected in the I - V curve at large bias. The resistance of the ZnO NW can thus be determined from the linear region via:

$$R_{ns} \approx \frac{dV}{dI} \Big|_{\text{large bias}}$$

By fitting the I - V characteristics derived from ZnO micro/nanowire sensors under different atmosphere and strain conditions (Fig. 2) with this GUI program, the Schottky barrier heights at drain electrode (Φ_d) are simulated and summarized in Fig. 5a and b for H_2 and NO_2 detections, respectively. As the reversely biased Schottky contact, the value of Φ_d effectively dominates the charge carriers transport process across the local interface [37,38]. Fig. 5a presents the SBH Φ_d in air, 80 ppm and 320 ppm hydrogen atmosphere under different strain conditions based on the experiment data presented in Fig. 2a-c; Fig. 5b

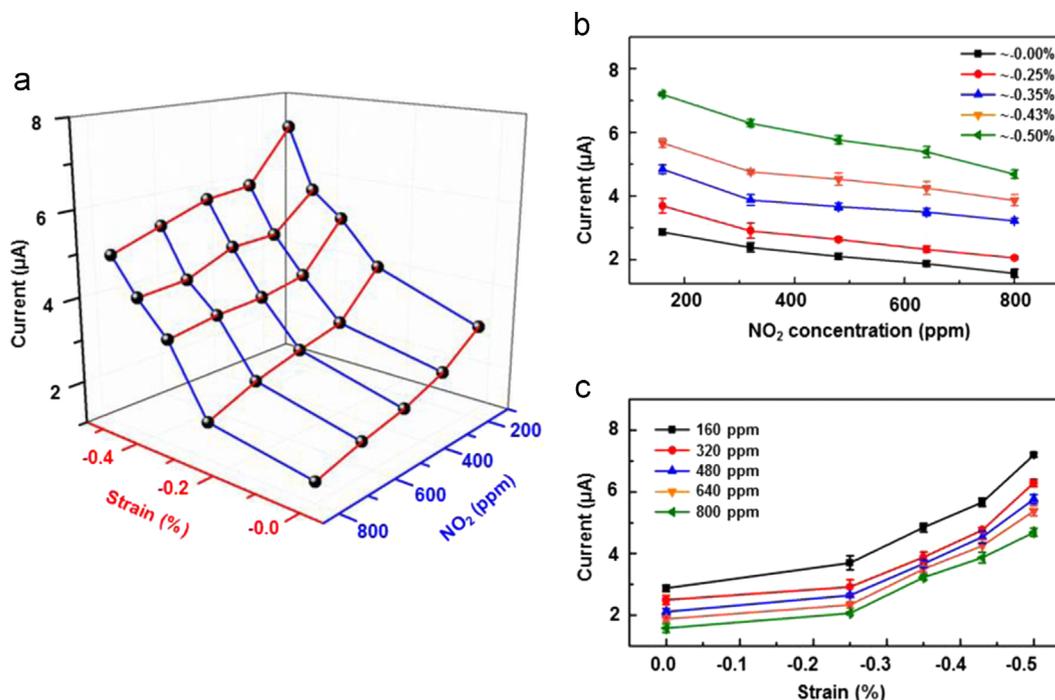


Fig. 4 Piezotronic enhancements on NO₂ sensing. (a) 3D graph depicting the current response of the NO₂ sensor to strain and NO₂ concentrations at a bias voltage of 4.8 V. (b) Absolute current response to different NO₂ concentrations, with compressive strains ranging from -0.00% to -0.50% . (c) Absolute current response to different compressive strains, with NO₂ concentrations ranging from 160 to 800 ppm.

shows the Φ_d in 160, 480 and 800 ppm NO₂ atmosphere under different strain conditions based on the experiment data presented in Fig. 2d-f. Both simulation results indicate obvious decrease of Φ_d as applying more compressive strains on the devices under each measurement atmosphere, corresponding to the enhancement of output current for both H₂ and NO₂ detections by piezotronic effect. Accordingly, the resistances of ZnO NWs are calculated and presented in Fig. 5c and d, showing consistency with the changes of Φ_d and also decreasing as increasing the externally applied compressive strains. These results agree well with the previous reports on gas sensing devices [39-42].

Band diagrams of ZnO NWs are carefully analyzed as shown in Fig. 6 to illustrate the physical working mechanism of ZnO H₂/NO₂ sensors and their piezotronic effect enhanced performances. A Schottky contact is formed at local M-S contact (reversely biased drain electrode) in air as shown in Fig. 6a. Once introducing hydrogen gas into the chamber, the adsorbed hydrogen molecules dissociate on the catalytic Pd nanoparticles by reacting with pre-existing O₂⁻ and releasing the trapped electrons to the conduction band of ZnO. Therefore, hydrogen molecules serve as donors by injecting electrons into ZnO conduction band to induce an accumulation layer of charge carriers on the surface of ZnO NW (Fig. 6c) and thus increase the conductivity and output current of the device. By introducing NO₂ gas into the chamber, the strong oxidizing NO₂ molecules interact with the oxygen vacancies or zinc interstitial [43] and become negatively charged units by draining electrons from the conduction band of ZnO. This process reduces the number of free electrons inside ZnO NW and

leads to a depletion layer [29] near the surface (Fig. 6e), decreasing the conductivity and output current of the ZnO micro/nanowire gas sensor [30]. Upon straining, based on the crystal orientation of ZnO (*c*-axis pointing from drain to source electrode) and the polarity of strains (compressive strains), positive piezoelectric polarization charges [37] are induced at the local M-S contact (Fig. 6b, d and f) and effectively reduce the barrier height of reversely biased Schottky contact. Thus piezotronic effect is employed to modify the band structure at M-S interface and contribute to the enhancements on output current as well as the general performances of ZnO micro/nanowire gas sensors.

Conclusion

In summary, we designed and fabricated flexible Schottky-contact ZnO micro/nanowire sensors for flammable/toxic gas detections. Both hydrogen (H₂) and nitrogen dioxide (NO₂) detections are demonstrated at room-temperature based on M-S-M structured devices. By utilizing strain-induced piezoelectric polarization charges presented at the vicinity of local interface to modify the band structure at Schottky contact, piezotronic effect has been introduced to gate/modulate the charge carriers transport process across the M-S contact and thus enhance/optimize the performances of H₂/NO₂ gas sensors. Upon straining, the detection sensitivity and resolution are obviously improved, together with a significant enhancement in output current by 5359% for H₂ and 238.8% for NO₂ detection. Band diagrams of ZnO NWs are carefully investigated to illustrate the working

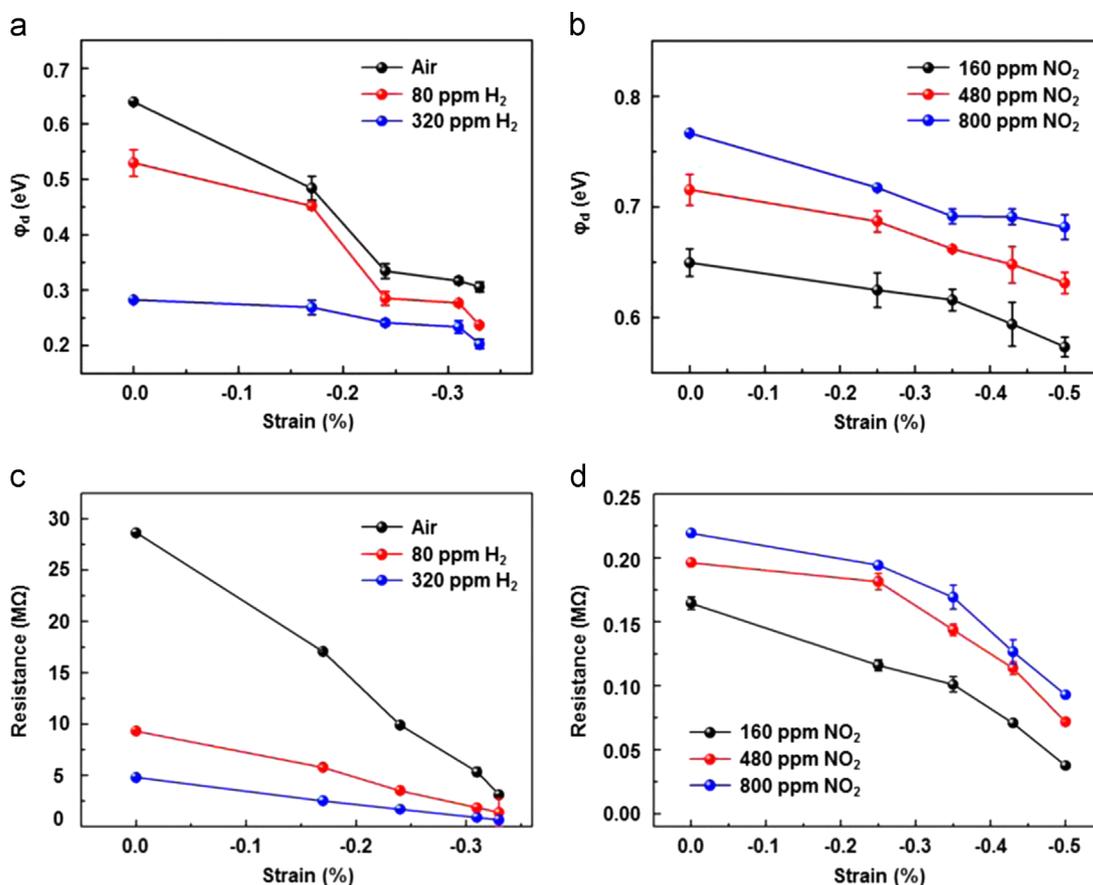


Fig. 5 Theoretical simulations of Δ SBH and Resistance. (a-b) The fitting results of SBH ϕ_d changes with compressive strains ranging from (a) -0.00% to -0.33% for H₂ sensing; (b) -0.00% to -0.50% for NO₂ sensing. (c-d) The fitting results of NW resistance changes with compressive strains ranging from (c) -0.00% to -0.33% for H₂ sensing; (d) -0.00% to -0.50% for NO₂ sensing.

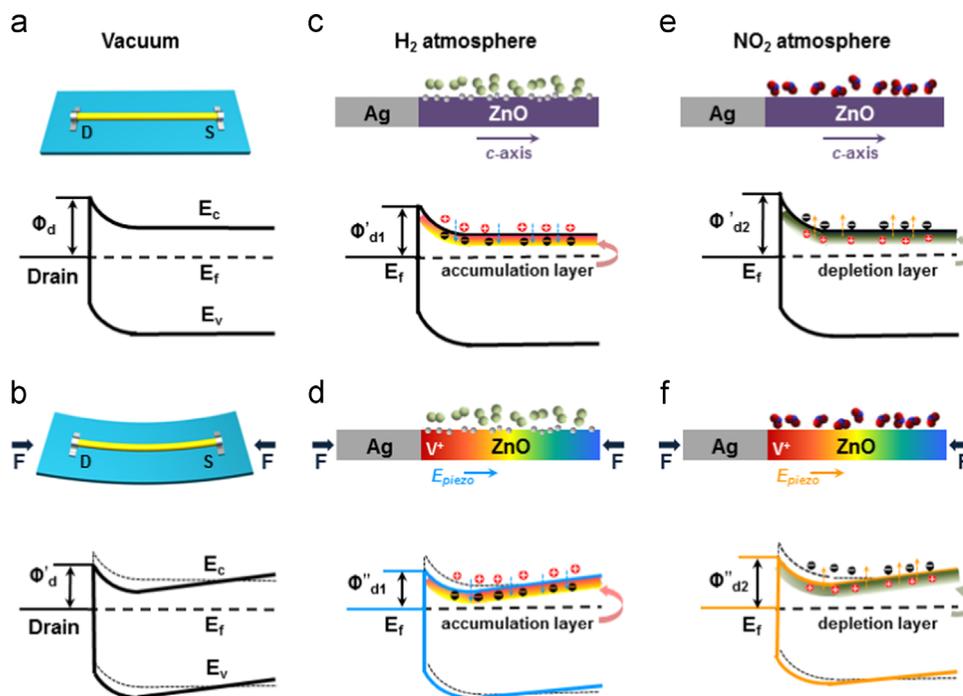


Fig. 6 Working mechanism. Schematic energy band diagrams of ZnO NW in (a) vacuum; (b) vacuum under compressive strains; (c) H₂ atmosphere; (d) H₂ atmosphere under compressive strains; (e) NO₂ atmosphere; (f) NO₂ atmosphere under compressive strains.

principle and the enhancement mechanism by piezotronic effect for H₂/NO₂ detections. This work provides a promising approach to raise the sensitivity, improve the detection resolution, and generally enhance the performance of Schottky-contact micro/nanowire gas sensors.

Acknowledgements

The authors are grateful for the support from the "Thousands Talents" program for pioneer researcher and his innovation team, China; President Funding of the Chinese Academy of Sciences; National Natural Science Foundation of China (No.51272238, 21321062, 51432005 and 61405040); the Beijing Municipal Science & Technology Commission (Z131100006013004, Z131100006013005).

References

- [1] Y. Cui, Q.Q. Wei, H.K. Park, C.M. Lieber, *Science* 293 (2001) 1289-1292.
- [2] Q. Kuang, C. Lao, Z.L. Wang, Z. Xie, L. Zheng, *J. Am. Chem. Soc.* 129 (2007) 6070-6071.
- [3] H. Huang, Y.C. Lee, O.K. Tan, W. Zhou, N. Peng, Q. Zhang, *Nanotechnology* 20 (2009).
- [4] X.Y. Kong, Z.L. Wang, *Nano Lett.* 3 (2003) 1625-1631.
- [5] Z.W. Pan, Z.R. Dai, Z.L. Wang, *Science* 291 (2001) 1947-1949.
- [6] A. Kolmakov, Y. Zhang, G. Cheng, M. Moskovits, *Adv. Mater.* 15 (2003) 997-1000.
- [7] C.S. Rout, K. Ganesh, A. Govindaraj, C.N.R. Rao, *Appl. Phys. A—Mater. Sci. Process.* 85 (2006) 241-246.
- [8] F. Yang, S.-C. Kung, M. Cheng, J.C. Hemminger, R.M. Penner, *ACS Nano* 4 (2010) 5233-5244.
- [9] Q.H. Li, Y.X. Liang, Q. Wan, T.H. Wang, *Appl. Phys. Lett.* 85 (2004) 6389-6391.
- [10] P. Offermans, M. Crego-Calama, S.H. Brongersma, *Nano Lett.* 10 (2010) 2412-2415.
- [11] Y. Cheng, P. Xiong, L. Fields, J.P. Zheng, R.S. Yang, Z.L. Wang, *Appl. Phys. Lett.* 89 (2006) 093114.
- [12] P. Andrei, L.L. Fields, J.P. Zheng, Y. Cheng, P. Xiong, *Sens. Actuators, B—Chem.* 128 (2007) 226-234.
- [13] T.Y. Wei, P.H. Yeh, S.Y. Lu, Z. Lin-Wang, *J. Am. Chem. Soc.* 131 (2009) 17690-17695.
- [14] Z.L. Wang, *Nano Today* 5 (2010) 540-552.
- [15] L. Chen, M.-C. Wong, G. Bai, W. Jie, J. Hao, *Nano Energy* (2014). <http://dx.doi.org/10.1016/j.nanoen.2014.11.039>.
- [16] G. Bai, M.-K. Tsang, J. Hao, *Adv. Opt. Mater.* (2014). <http://dx.doi.org/10.1002/adom.201400375>.
- [17] X.D. Wang, J. Zhou, J.H. Song, J. Liu, N.S. Xu, Z.L. Wang, *Nano Lett.* 6 (2006) 2768-2772.
- [18] J. Zhou, Y.D. Gu, P. Fei, W.J. Mai, Y.F. Gao, R.S. Yang, G. Bao, Z.L. Wang, *Nano Lett.* 8 (2008) 3035-3040.
- [19] P.H. Yeh, Z. Li, Z.L. Wang, *Adv. Mater.* 21 (2009) 4975-4978.
- [20] C.F. Pan, R.M. Yu, S.M. Niu, G. Zhu, Z.L. Wang, *ACS Nano* 7 (2013) 1803-1810.
- [21] R.M. Yu, C.F. Pan, J. Chen, G. Zhu, Z.L. Wang, *Adv. Funct. Mater.* 23 (2013) 5868-5874.
- [22] R.M. Yu, C.F. Pan, Z.L. Wang, *Energ. Environ. Sci.* 6 (2013) 494-499.
- [23] Q. Yang, X. Guo, W.H. Wang, Y. Zhang, S. Xu, D.H. Lien, Z.L. Wang, *ACS Nano* 4 (2010) 6285-6291.
- [24] R.M. Yu, C.F. Pan, Y.F. Hu, L. Li, H.F. Liu, W. Liu, S. Chua, D.Z. Chi, Z.L. Wang, *Nano Res.* 6 (2013) 758-766.
- [25] G.F. Hu, R.R. Zhou, R.M. Yu, L. Dong, C.F. Pan, Z.L. Wang, *Nano Res.* 7 (2014) 1083-1091.
- [26] R. Nowakowski, R. Dus, *Langmuir* 19 (2003) 6750-6758.
- [27] H.T. Wang, B. Kang, F. Ren, L. Tien, P. Sadik, D. Norton, S. Pearton, J. Lin, *Appl. Phys. Lett.* 86 (2005) 243503.
- [28] T.B. Fryberger, S. Semancik, *Sens. Actuators, B—Chem.* 2 (1990) 305-309.
- [29] A.Z. Sadek, S. Choopun, W. Wlodarski, S.J. Ippolito, K. Kalantar-Zadeh, *IEEE Sens. J.* 7 (2007) 919-924.
- [30] Y. Shimizu, M. Egashira, *MRS Bull.* 24 (1999) 18-24.
- [31] X.D. Wang, C.J. Summers, Z.L. Wang, *Nano Lett.* 4 (2004) 423-426.
- [32] G. Zhu, Y.S. Zhou, S.H. Wang, R.S. Yang, Y. Ding, X. Wang, Y. Bando, Z.L. Wang, *Nanotechnology* 23 (2012).
- [33] A. Kolmakov, D.O. Klenov, Y. Lilach, S. Stemmer, M. Moskovits, *Nano Lett.* 5 (2005) 667-673.
- [34] M. Chen, Z. Wang, D. Han, F. Gu, G. Guo, *J. Phys. Chem. C* 115 (2011) 12763-12773.
- [35] M. Law, H. Kind, B. Messer, F. Kim, P.D. Yang, *Angew. Chem. Int. Ed.* 41 (2002) 2405-2408.
- [36] Y. Liu, Z.Y. Zhang, Y.F. Hu, C.H. Jin, L.M. Peng, *J. Nanosci. Nanotechnol.* 8 (2008) 252-258.
- [37] R.M. Yu, L. Dong, C.F. Pan, S.M. Niu, H.F. Liu, W. Liu, S. Chua, D.Z. Chi, Z.L. Wang, *Adv. Mater.* 24 (2012) 3532-3537.
- [38] Z.L. Wang, *Adv. Mater.* 19 (2007) 889-892.
- [39] C. Baratto, G. Sberveglieri, A. Onischuk, B. Caruso, S. di Stasio, *Sens. Actuators, B—Chem.* 100 (2004) 261-265.
- [40] J.H. Jun, J. Yun, K. Cho, I.-S. Hwang, J.-H. Lee, S. Kim, *Sens. Actuators, B—Chem.* 140 (2009) 412-417.
- [41] M.W. Ahn, K.S. Park, J.H. Heo, D.W. Kim, K.J. Choi, J.G. Park, *Sens. Actuators, B—Chem.* 138 (2009) 168-173.
- [42] T.-R. Rashid, D.-T. Phan, G.-S. Chung, *Sens. Actuators, B—Chem.* 193 (2014) 869-876.
- [43] M. Epifani, J.D. Prades, E. Comini, E. Pellicer, M. Avella, P. Siciliano, G. Faglia, A. Cirera, R. Scotti, F. Morazzoni, J. R. Morante, *J. Phys. Chem. C* 112 (2008) 19540-19546.



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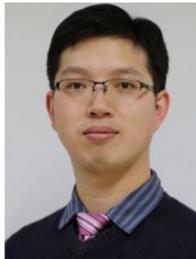


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